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July 2019



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**Idaho National Laboratory  
Idaho Falls, Idaho 83415**

**<http://www.inl.gov>**

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**K.L. Davis<sup>a</sup>, A. Gusarov<sup>b</sup>, T.C. Unruh<sup>a</sup>, P. Calderoni<sup>a</sup>, B. J. Heidrich<sup>a</sup>, K. M. Verner<sup>a</sup>, S. Van Dyck<sup>b</sup>, I. Uytendhouwen<sup>b</sup>, A. Al Rashdan<sup>a</sup>, A.A. Lambson<sup>a</sup>**

**<sup>a</sup> Idaho National Laboratory**

**<sup>b</sup> SCK•CEN Belgian Nuclear Research Centre**

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# Introduction



Since the early 1960s, SiC has been used as a post-irradiation temperature monitor.

- Neutron irradiation induced lattice expansion of SiC anneals out when the post-irradiation annealing temperature exceeds the peak irradiation temperature
- Irradiation temperature is determined by measuring a property change after isochronal annealing or during a continuously monitored annealing process
- There are many properties that may be measured including, electrical resistivity (method used), density, thermal diffusivity, lattice spacing, and thermal expansion.
- Peak irradiation temperatures 150 – 800°C
- Recommended dose 1 – 8 dpa
- Irradiation testing completed March 2017 electrical resistivity evaluations started March 2018 completed July 2018.

# Introduction

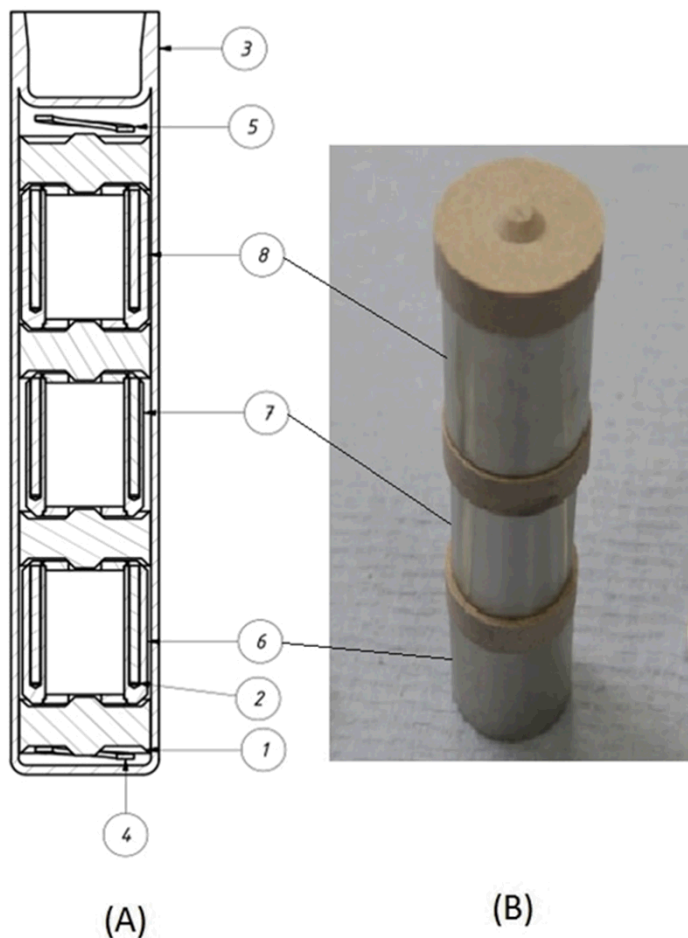
	Measurement Accuracy	Calculated	Property Change @ 500°C Irradiation	Property Recovery above Irradiation Temperature (%/10°C anneal)	Recommended Sample Type	Technique Accuracy and Comments
Dimensional Change	0.0003 mm	0.5%	~0.007	~3	12.7 mm L, 3.17 mm Diam Extreme    Extreme Flatness	Measurement accuracy 12°C at 450°C 70°C at 700°C
Electrical Resistivity (method used)	0.01-1 %	N?A	~0.3	~0.03	Bar 0.75 x 1 x Length	Within 20°C
Thermal Diffusivity	1 – 5%	90%	~0.08	~13	2-4 mm L, 6-10 mm dia.	Within 40°C Good when length is limitation
Density Gradient Column	~0.1%	0.5%	~0.021%	~5	Random, small	Within 30°C, Time consuming unless multiple samples irradiation. Good for small samples
Lattice Spacing						Accuracy uncertain, Time consuming

# Method



- Equipment used to evaluate the SiC temperature monitors.
  - Annealing furnace using isochronal temperature steps.
  - Resistivity measurement fixture located in the constant temperature chamber (maintained at 40°C) for a minimum of 30 minutes.
  - After the 30 minute wait time, each specimen's resistance is measured.

# Irradiation Capsule



- Basket for Material Irradiation (BAMI) Rig
  - (A) Cross-section of the aluminum irradiation capsule (3), stainless steel holders (6, 7 and 8) for SiC monitors (2). The holders are separated with ceramic discs (1) which are held in place with springs (4 and 5).
  - (B) Three holders and the three ceramic spacers stacked before irradiation.

# Calculated Dose and Peak Irradiation Temperature

## Dose Calculation

- Flux MCNP and cross sections SPECTER (based on ATR flux)

$$DPA_{rate} = \int_{E_m}^{E_M} \sigma_d(E) \phi(E) dE$$

- Second calculation MCNPX using BR2 F4 tally cards
- Both calculations produced comparable dose.

## Thermal Analysis (2D)

- Analytic Solution

$$\frac{1}{r} \frac{d}{dr} \left( k_i r \frac{dT_i}{dr} \right) + q_i = 0, i = 1 \dots n$$

where  $i$  is the layer number,  $n = 4$ . The following boundary conditions were applied:

$$T_1(0) < \infty$$

$$T_i(r = r_i) = T_{i+1}(r = r_i)$$

$$k_i \frac{dT_i}{dr}(r = r_i) = k_{i+1} \frac{dT_{i+1}}{dr}(r = r_i)$$

$$-k_n \frac{dT_n}{dr}(r = r_n) = h[T_n(r_n) - T_\infty]$$

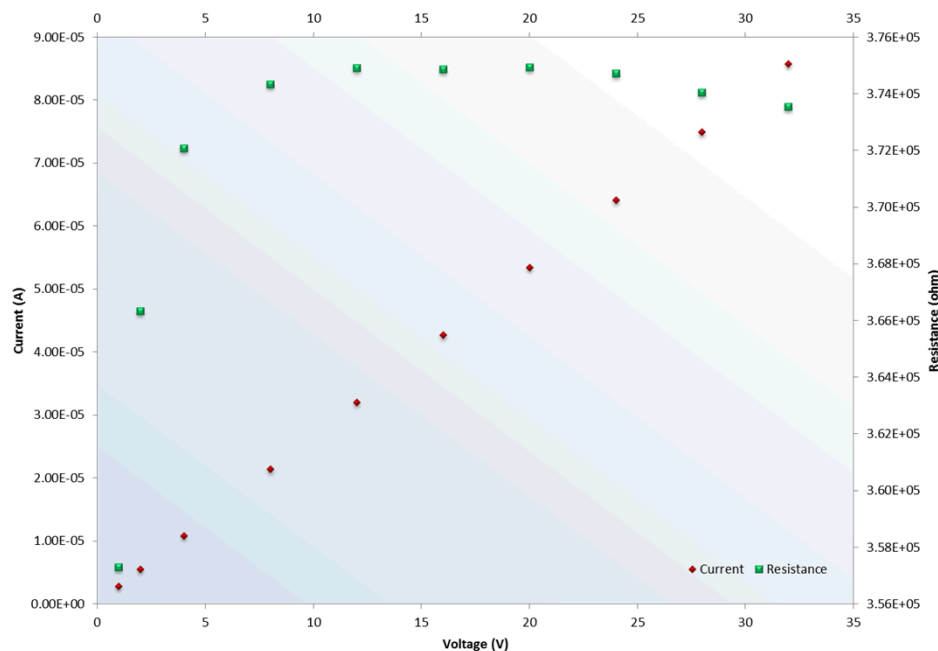
where  $T_\infty$  is the coolant temperature.

- Confirmed with ANSYS numerical simulations

Monitor Identification	Dose (dpa)	Calculated Peak Irradiation Temperature (°C)
BR2 M1-Low-A	0.5	255°C
BR2 M2-Low-A	1.1	255°C
BR2 M1-High-A	0.5	310°C
BR2 M2-High-A	1.1	310°C
BR2 M1-Med-A	0.5	410°C
BR2 M2-Med-A	1.1	410°C



# SiC Temperature Monitor Evaluations

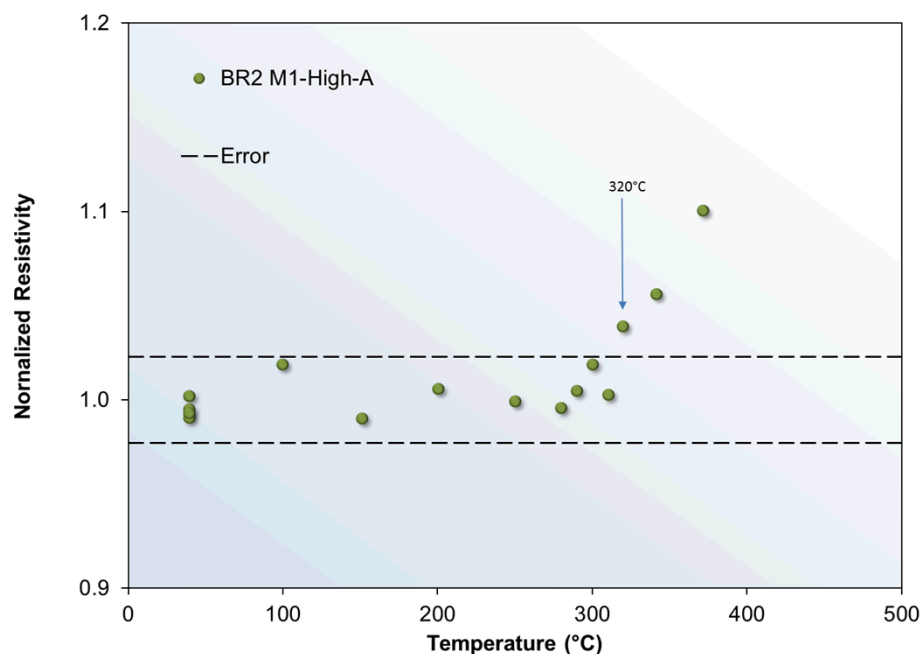


## Ohmic response curve

- Generated for each monitor prior to heating
- Check for linearity.
- Select target voltage (with corresponding current) to minimize heating.
- Voltage ranged from 16 – 20V.

Typical ohmic response as demonstrated by SiC temperature monitor BR2 M1-High-A

# SiC Temperature Monitor Evaluations



## Peak irradiation temperature

- Electrical resistivity technique
- Evaluation point where the resistivity begins, and consistently remains, above the error band (dotted lines)
- Error band established as  $\pm 2\sigma$  (based on first five data points taken below 150°C).

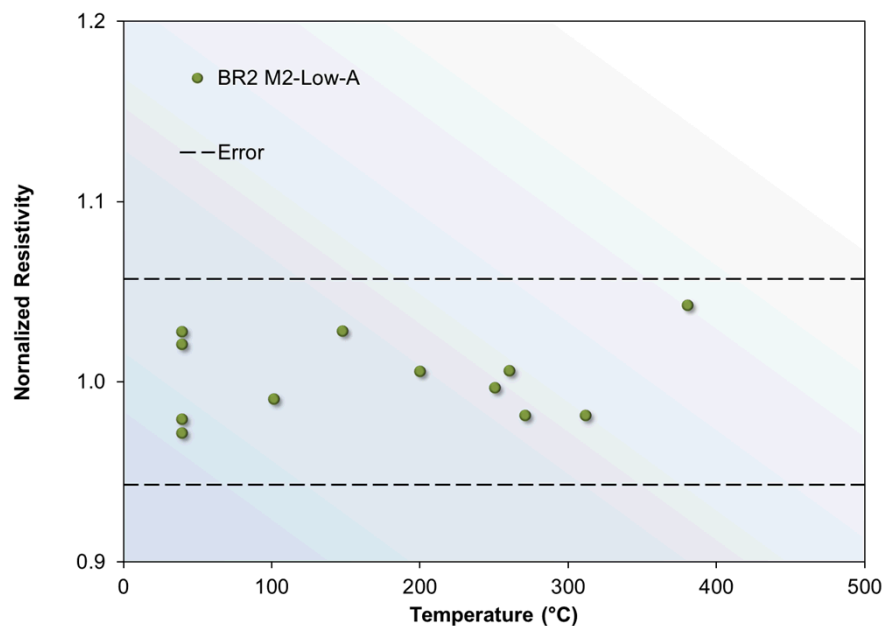
Typical peak irradiation temperature evaluation as demonstrated by SiC temperature monitor BR2 M1-High-A

# ***SiC Temperature Monitor Evaluations***

ID	Measured	Calculated	Deviation (measured - calculated)	% Deviation	Initial resistivity at 40°C
BR2 M1-Low-A	240°C	255°C	-15°C	-6%	20 ( $\Omega$ -m)
BR2 M2-Low-A	Indeterminate	255°C	n/a	n/a	16 ( $\Omega$ -m)
BR2 M1-High-A	320°C	310°C	10°C	3%	24 ( $\Omega$ -m)
BR2 M2-High-A	330°C	310°C	20°C	6%	14 ( $\Omega$ -m)
BR2 M1-Med-A	390°C	410°C	-20°C	-5%	43 ( $\Omega$ -m)
BR2 M2-Med-A	380°C	410°C	-30°C	-8%	25 ( $\Omega$ -m)

- All of the monitors responded with the exception of the BR2 M2-Low-A.
- BR2 M2-Med-A outside of the expected deviation of 20°C

# SiC Temperature Monitor Evaluations

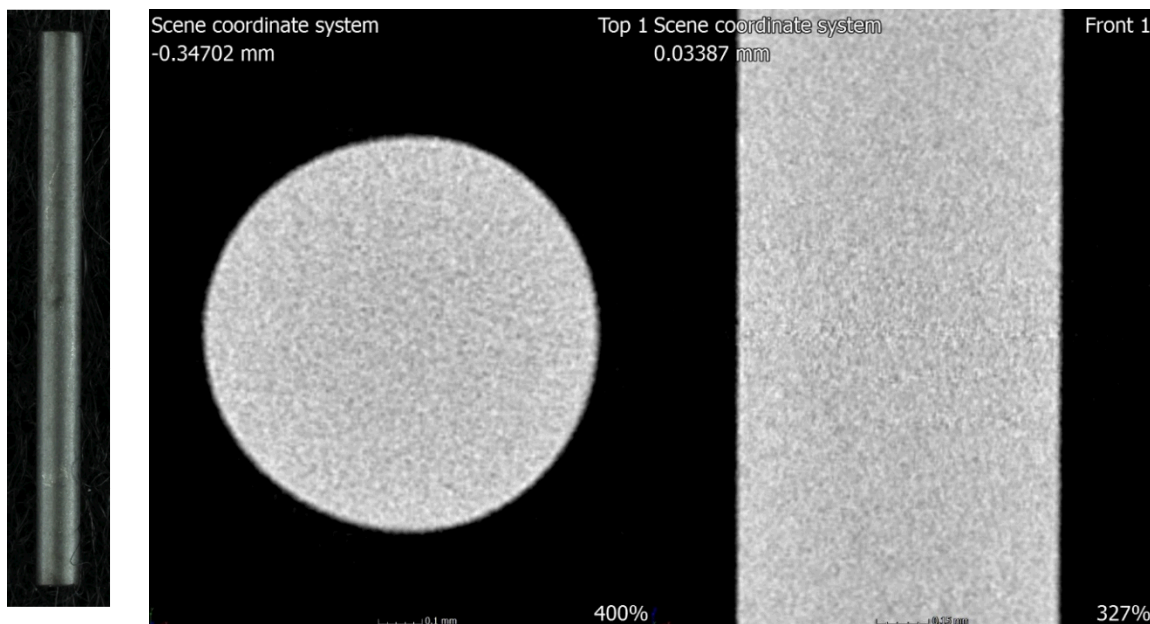


## BR2 M2-Low-A

- No response
- Lowest dose, 0.5 dpa
- Lowest temperature exposure (255°C).
- Very large error band

Evaluation data for BR2 M2-Low-A

# 3D Micro-focus Computed Tomography



## BR2 M2-Low-A

- Scan @50 kV, resolution of 6  $\mu\text{m}$
- Uniform density
- No voids or cracks
- Destructive examination next, including SEM

## ***Conclusion***

- Successful evaluation of SiC temperature monitors irradiated in BR2 as part of an NSUF Project.
- Resistivity method proved robust.
- Low dose (0.5 dpa) SiC monitors may be evaluated within 240 – 380° C.

